

PATENT

Reg. No. AMAT/5027/02/CPVCCP/00000000

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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MAY 19 2004

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In re Application of:
Chen, et al.

Serial No.: 10/050,654

Confirmation No.: 6065

Filed: January 16, 2002

For: Method for Growing Thin
Films by Catalytic
Enhancement

Group Art Unit: 1762

Examiner: Timothy H. Meeks

MAIL STOP AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450CERTIFICATE OF FACSIMILE
TRANSMISSION UNDER 37 CFR 1.6I hereby certify that this correspondence and the documents
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Signature

Dear Sir:

CORRECTED RESPONSE TO FINAL OFFICE ACTION DATED FEBRUARY 19, 2004

In response to the Final Office Action dated February 19, 2004, having a shortened statutory period for response set to expire on May 19, 2004, please enter this response and reconsider the claims pending in the application for reasons discussed below. Applicant notes that the terminal disclaimer filed on April 19, 2004, has been entered by the Office. Although Applicant believes that no additional fees are due in connection with this response, the Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/AMAT/5027.02/KMT, for any fees, including extension of time fees or excess claim fees, required to make this response timely and acceptable to the Office.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper. Remarks begin on page 5 of this paper.

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